

Compressed Sensing Applications in Microscopy and Microanalysis

Joshua Taillon CS-Bio-Met meeting - May 18, 2017



MATERIAL MEASUREMENT LABORATORY

Outline

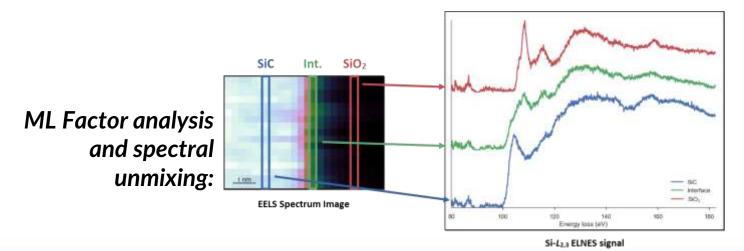
- Introduction (about me)
- Brief (and basic) introduction to CS
- Existing applications of CS in microscopy
- Our work (in progress)
- Future ideas





Introduction

- NRC Postdoc in Materials Measurements Science Division
 - Microscopy and Microanalysis Research Group
- Background in Materials Characterization:
 - TEM, FIB/SEM, EELS/EDS spectroscopies







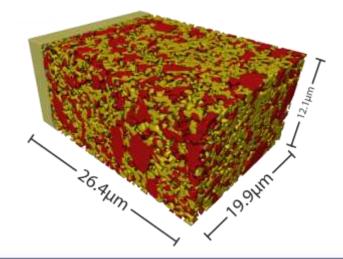
- NRC Postdoc in Materials Measurements Science Division
 - Microscopy and Microanalysis Research Group
- Background in Materials Characterization:
 - TEM, FIB/SEM, EELS/EDS spectroscopies





- NRC Postdoc in Materials Measurements Science Division
 - Microscopy and Microanalysis Research Group
- Background in Materials Characterization:
 - TEM, FIB/SEM, EELS/EDS spectroscopies

Three dimensional nanotomography and microstructure analysis:



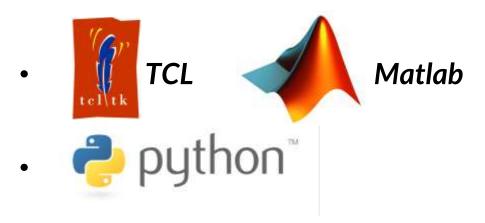






NIST

- NRC Postdoc in Materials Measurements Science Division
 - Microscopy and Microanalysis Research Group
- Background in Materials Characterization:
 - TEM, FIB/SEM, EELS/EDS spectroscopies







Research Interests

- Lots of opportunity at intersection of microscopy and computer science/mathematics
 - Active learning
 - Novel data analysis methods
 - Automated tool control
 - Compressed sensing





Brief intro to compressed sensing

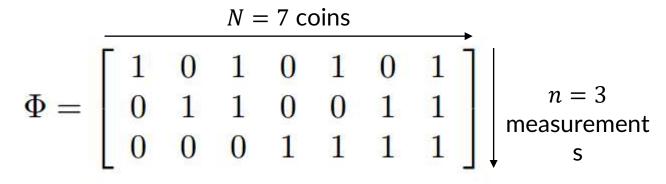
Motivating example

- Assume you have 7 coins
 - One is counterfeit with a different mass than the others
 - Easy solution would be to measure the mass of each individual coin
 - Can we do better?

Good introductions in: E.J. Candès and M.B. Wakin, <u>An Introduction</u> <u>To Compressive Sampling</u>, *IEEE Signal Process. Mag.* **25**, 21 (2008). K. Bryan and T. Leise, <u>Making Do with Less: An Introduction to</u> <u>Compressed Sensing</u>, *SIAM Rev.* **55**, 547 (2013).

Motivating example

- Assume you have 7 coins
 - One is counterfeit with a different mass than the others
 - Easy solution would be to measure the mass of each individual coin
 - Can we do better?
- Measure groupings of coins instead:
 - Only 3 measurements needed



Good introductions in: E.J. Candès and M.B. Wakin, <u>An Introduction</u> <u>To Compressive Sampling</u>, *IEEE Signal Process. Mag.* **25**, 21 (2008). K. Bryan and T. Leise, <u>Making Do with Less: An Introduction to</u> <u>Compressed Sensing</u>, *SIAM Rev.* **55**, 547 (2013).



Motivating example

- Assume you have 7 coins
 - One is counterfeit with a different mass than the others
 - Easy solution would be to measure the mass of each individual coin
 - Can we do better?
- Measure groupings of coins instead:
 - Only 3 measurements needed
 - More generally,
 - $n \approx \log_2(N) \ll N$

$$\Phi = \begin{bmatrix} 1 & 0 & 1 & 0 & 1 & 0 & 1 \\ 0 & 1 & 1 & 0 & 0 & 1 & 1 \\ 0 & 0 & 0 & 1 & 1 & 1 & 1 \end{bmatrix} \begin{bmatrix} n = 3 \\ measurement \\ s \end{bmatrix}$$

Good introductions in: E.J. Candès and M.B. Wakin, <u>An Introduction</u> <u>To Compressive Sampling</u>, *IEEE Signal Process. Mag.* **25**, 21 (2008). K. Bryan and T. Leise, <u>Making Do with Less: An Introduction to</u> <u>Compressed Sensing</u>, *SIAM Rev.* **55**, 547 (2013).



More general CS formalism

- Φ is $n \times N$ "sensing matrix"
 - We are trying to recover an unknown *sparse* vector $\mathbf{x} \in \mathbb{R}^N$ with a measurement vector \mathbf{b} and a known sensing matrix $\boldsymbol{\Phi}$
 - x is sparse (mostly zeros), and describes which coin is different
 - We want to find a sparse solution that satisfies $\Phi x = b$, given:

$$\mathbf{b} = \begin{bmatrix} 1\\1\\0 \end{bmatrix} \qquad \Phi = \begin{bmatrix} 1 & 0 & 1 & 0 & 1 & 0 & 1\\ 0 & 1 & 1 & 0 & 0 & 1 & 1\\ 0 & 0 & 0 & 1 & 1 & 1 & 1 \end{bmatrix} \qquad \mathbf{x} = \begin{bmatrix} 2\\2\\2\\2\\2\\2\\2\end{bmatrix}$$

13

г7л

More general CS formalism

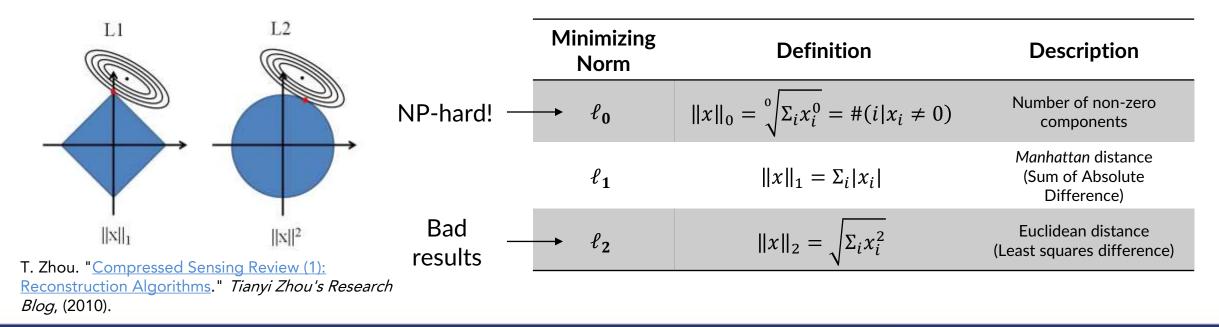
- How do we determine Φ ?
 - Strictly speaking, it must obey the "restricted isometry principle" (RIP)
 - RIP means that if we select K random columns from Φ , that submatrix is full rank
 - Designing a Φ to satisfy the RIP is actually NP-hard, but it turns out it's not necessary for a successful recovery of x, just sufficient
 - Turns out that a random binary matrix will satisfy RIP (with high probability)
 - In practically all implementations of CS, this random sampling is what is used



More general CS formalism

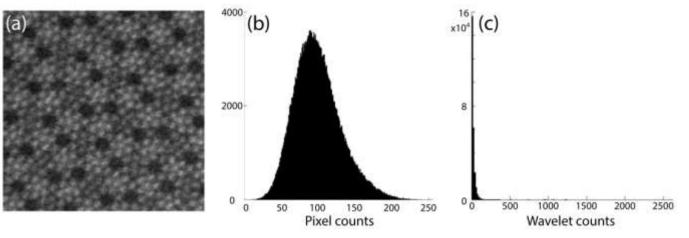
NIST

- Φ has fewer rows than columns, so $\Phi x = b$ is underdetermined
 - This means there are an infinite number of solutions
- The "magic" of compressed sensing is the use of the ℓ_1 norm for convex optimization to find the "best" x (when using the right Φ)



Why "compressed" sensing?

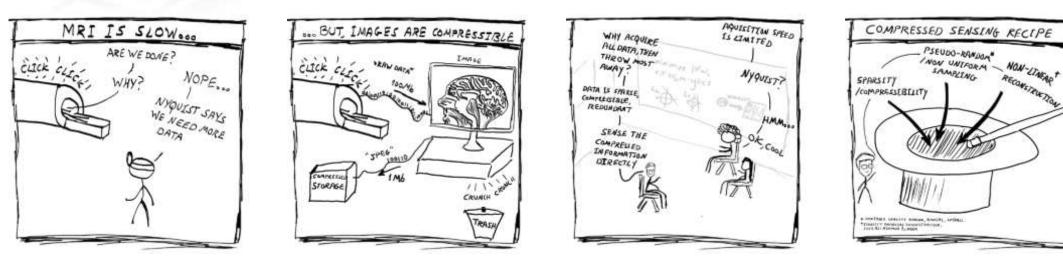
- Consider a "compressible" HRTEM image:
 - In the pixel basis, many coefficients needed to encode the image
 - In the wavelet basis, very few coefficients are needed
 - Idea behind JPEG, etc.



Adapted from P. Binev *et al.*, "Compressed Sensing and Electron Microscopy" in Modeling Nanoscale Imaging Electron Microscopy (2012).

• What if we could measure the sparse basis directly?

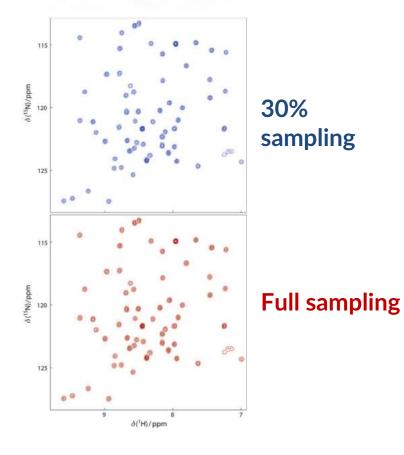
Areas of initial success - MRI



Comics from Michael Lustig

- Subsampling k-space greatly reduces number of acquisitions needed, and time for patient
 - Greatly expands indications for MRI (pediatrics, compromised health, etc.)
 - After 10 years, first FDA-approved applications of CS-MRI on the market in Feb. 2017 (link)
- Compressed sensing saves lives!
 - J. Ellenberg, "<u>Fill in the Blanks: Using Math to Turn Lo-Res Datasets Into Hi-Res</u> <u>Samples</u>," *Wired* (2010).

Areas of initial success – NMR Spectroscopy



- Multidimensional nuclear magnetic resonance
 - NMR spectra are typically sparse few isolated peaks in the Fourier domain
 - Measured 30% of the 128 complex data pairs
 - Measurement time: 165 min \rightarrow 50 min
- Observed very high fidelity reconstructions w.r.t. peak positions and shape/intensity

D.J. Holland, et al., Fast Multidimensional NMR Spectroscopy Using Compressed Sensing, Angew. Chemie Int. Ed. 50, 6548 (2011).





Efforts in CS for electron microscopy

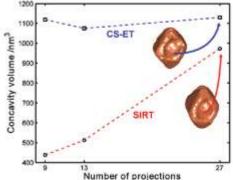
CS in TEM (electron tomography – CS-ET)

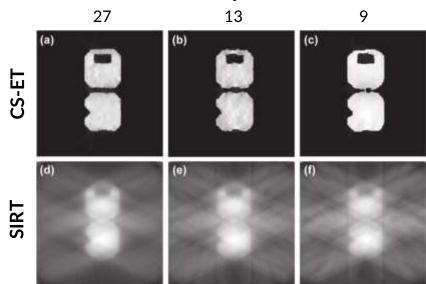
- Tilt-tomography finds 3D representations of objects in the TEM by acquiring 2D images at many tilt angles
 - Can reduce number of tilted images needed using CS principles and compare results to the standard *simultaneous iterative reconstruction technique* (SIRT)
- Tomography of iron oxide nanoparticles:
 - CS-ET performs significantly better than SIRT, at all signal levels

Z. Saghi, *et al.* <u>Three-dimensional morphology of iron</u> oxide nanoparticles with reactive concave surfaces. A compressed sensing-electron tomography (CS-ET) approach, *Nano Lett.* **11**, 4666 (2011).

R.K. Leary, *et al.*, <u>Compressed sensing electron</u> <u>tomography</u>, *Ultramicroscopy*. **131**, 70 (2013).

NIST

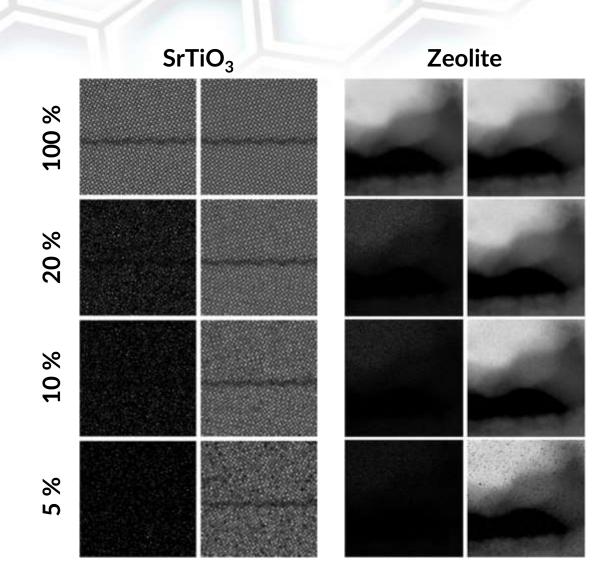




of Projections

CS in STEM (imaging)

- Benefits of reduced sampling in STEM:
 - Reduced dose (for electron-sensitive materials)
 - Reduced time/increased throughput
- Random sampling in pixeldomain
 - Bayesian factor analysis to find sparse representation (BPFA)
 - Sampling done with beam blanker or meandering beam



A. Stevens, *et al.*, <u>The potential for Bayesian compressive sensing to significantly reduce</u> electron dose in high-resolution STEM images, Microscopy. 63, 41 (2014).



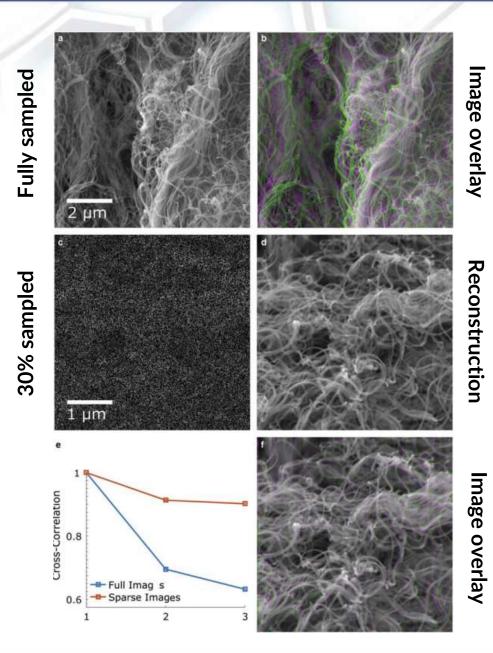
CS in SEM

- Two published implementations:
 - H.S. Anderson, et al., <u>Sparse imaging for fast electron microscopy</u>, Proc. SPIE-IS&T Electron. Imaging. 8657 (2013).
 - Use a split Bregman formulation of basis-pursuit for ℓ_1 minimization
 - Drive beam to random pixels, taking care to account for scan coil dynamics
 - 10x imaging speedup when imaging only 10% of pixel locations (linear response)
 - K. Hujsak, *et al.*, <u>Suppressing Electron Exposure Artifacts: An Electron Scanning Paradigm with</u> <u>Bayesian Machine Learning</u>, Microscopy and Microanalysis, 1–11 (2016).
 - Use the same BPFA as in Stevens' CS-STEM
 - No scan coil modifications to SEM (just need high-speed beam blanker)
 - Did not demonstrate significant speed gains, but did significantly reduce dose

CS in SEM

NIST

- K. Hujsak, et al., <u>Suppressing Electron</u> <u>Exposure Artifacts: An Electron Scanning</u> <u>Paradigm with Bayesian Machine Learning</u>, Microscopy and Microanalysis, 1–11 (2016).
 - Analyzed effect of reduced dose from CS-SEM on electron-sensitive human collagen sample
 - Significant reduction in sample modification due to beam-damage
- Also tested various scan patterns
 - Random sampling was found to perform better than spiral, Lissajous, and random line sampling
 - Highest reconstructed PSNR and least number of scanning artifacts



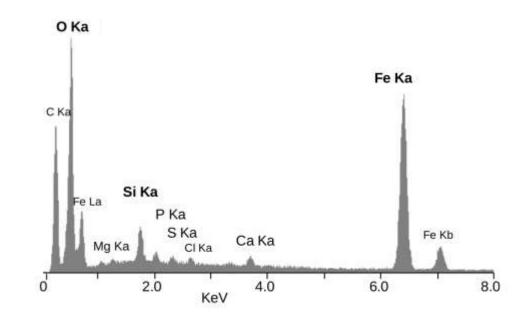


Our initial work

Our goals

NIST

- Originally set out to implement what was published by Hujsak
 - Have pivoted instead to see what impact we can have in the analytical realm
 - One conference paper on CS in STEM-EELS, but nothing else (yet)
 - Given our preference for FIB/SEM, we'll focus on X-ray analysis (EDS)
 - Long dwell times needed
 - Acquisitions will damage beam-sensitive materials
 - Seems ripe for "disruption"



Strategy

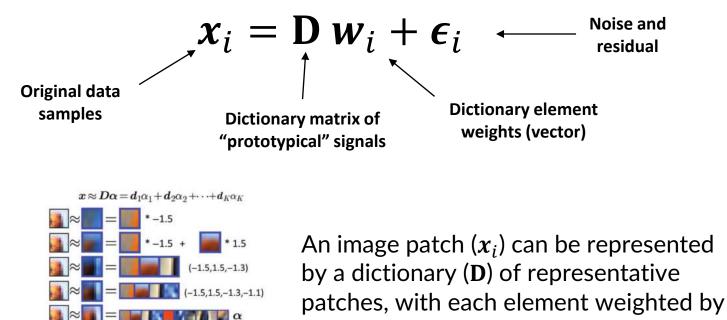
- Identify existing reconstruction algorithm that is purpose-built for hyperspectral imaging (HSI) data
 - The hyperspectral remote sensing community has been much faster to adopt advanced data analysis methods (like CS) than the microscopy community
- Demonstrate control and implement on existing HSI data
- Apply to simulated EDS data to determine/quantify effectiveness
- Determine what (if any) performance enhancement can be gained on live experiments



BPFA = Beta-Bernoulli Process Factor Analysis

 α

- Factor analysis
 - Decompose signal into a linear approximation of factors and weights



a factor from w (plus some noise ϵ)

Figure from: A. Stevens, et al. Microscopy. **63**, 41 (2014). Note: $w_i = \alpha_i$ in this paper's notation



BPFA = Beta-Bernoulli Process Factor Analysis

- How to find D and w?
 - Bayesian beta-Bernoulli Process
- We infer the underlying signal $x_i = Dw_i$ by:
 - Placing Bayesian priors on **D**, w_i , and ϵ_i
 - Assuming that w_i is sparse
 - Iterate on each parameter to improve the estimation of their values (based on observed data)

Details about algorithms in:

- M. Zhou, et al., Nonparametric bayesian dictionary learning for analysis of noisy and incomplete images, IEEE Trans. Image Process. 21, 130–144 (2012)
- Z. Xing, et al., Dictionary Learning for Noisy and Incomplete Hyperspectral Images, SIAM J. Imaging Sci. 5, 33–56 (2012).



BPFA Formalism

- What does beta-Bernoulli Process mean in practice?
 - BP is a strategy for updating w_i in a Bayesian manner
- Define w_i as $z_i \odot s_i$:
 - • • = element-wise multiplication
 - *s_i* are the dictionary weights
 - *z_i* are "binary indicators", specifying which of the *K* columns of *D* are used to represent *x_i*:
 - \mathbf{z}_i are drawn from a Bernoulli distribution:

$$\mathbf{z}_i \sim \prod_{k=1}^{K} \text{Bernoulli}(\pi_k)$$

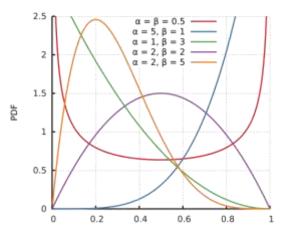
• Where π_k is the *k*th component of:

$$\boldsymbol{\pi} \sim \prod_{k=1}^{K} \operatorname{Beta}\left(\frac{a}{K}, \frac{b(K-1)}{K}\right)$$

Bernoulli Distribution

$$f(k;p) \begin{cases} p & \text{if } k = 1, \\ 1-p & \text{if } k = 0. \end{cases}$$

Beta Distribution





BPFA Formalism

- Full model parameters:
 - $x_i = \mathbf{D}w_i + \epsilon_i$
 - $w_i = z_i \odot s_i$
 - $\boldsymbol{d}_k \sim \mathcal{N}(0, P^{-1} \mathbf{I}_{\mathrm{P}})$
 - $\mathbf{s}_{i} \sim \mathcal{N}(0, \gamma_{s}^{-1}\mathbf{I}_{K})$
 - $\boldsymbol{\epsilon}_{i} \sim \mathcal{N}(0, \gamma_{\epsilon}^{-1} \mathbf{I}_{P})$
 - $\mathbf{z}_i \sim \prod_{k=1}^{K} \text{Bernoulli}(\pi_k)$
 - $\boldsymbol{\pi} \sim \prod_{k=1}^{K} \operatorname{Beta}\left(\frac{a}{K}, \frac{b(K-1)}{K}\right)$

- More definitions:
 - ~ means a Bayesian variable drawn from the specified prior distribution
 - $\mathcal{N}(i, j)$ specifies a normal distribution with mean *i* and variance *j*
 - γ_i are conjugate hyperpriors of the form $\gamma_s \sim \text{Gamma}(c, d)$ and $\gamma_\epsilon \sim \text{Gamma}(e, f)$
 - *d_k* represents the *k*th component (column) of **D**



How does it work?

- The model is inferred using <u>Gibbs Sampling</u>
 - Markov chain Monte Carlo algorithm used to sample the full Bayesian likelihood
 - Samples from the posterior distribution of each random variable are estimated by iteratively sampling from the conditional distributions of each variable (given all the others)
 - After "enough" iterations, the estimated variables are likely close to the true model parameters

• Such a method determines both the dictionary and weights iteratively

- Can be used on plain imagery (like <u>Anderson</u> and <u>Hujsak</u>)
- Also developed for hyperspectral imagery (by <u>Xing</u>)



What does it look like in practice?

- Example data from algorithm authors:
 - Hyperspectral imagery (HSI) from satellite imaging of an urban environment
 - 150 x 150 spatial pixels 210 spectral bands
 - Artificially remove some large fraction of voxels, and reconstruct using BPFA:



What does it look like in practice?

Original data

2% sampling

2x2 patch size



4x4 patch size



PSNR = 24.00 dB

Spectral Channel 100

PSNR = 8.77 dB

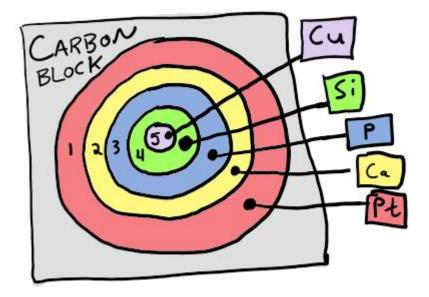
Center pixel spectrum

NIST

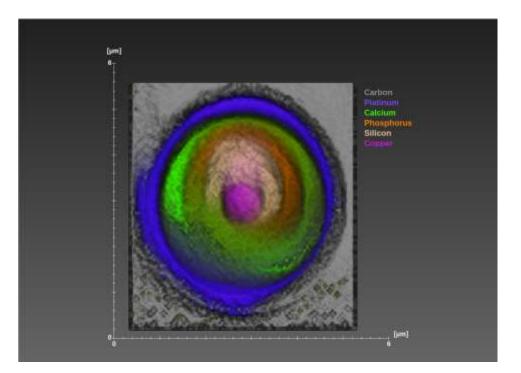


How about EDS?

- Simulated 3D data cube using DTSA-II:
 - 100 x 100 spatial 2048 spectral channels



Schematic of spherical geometry

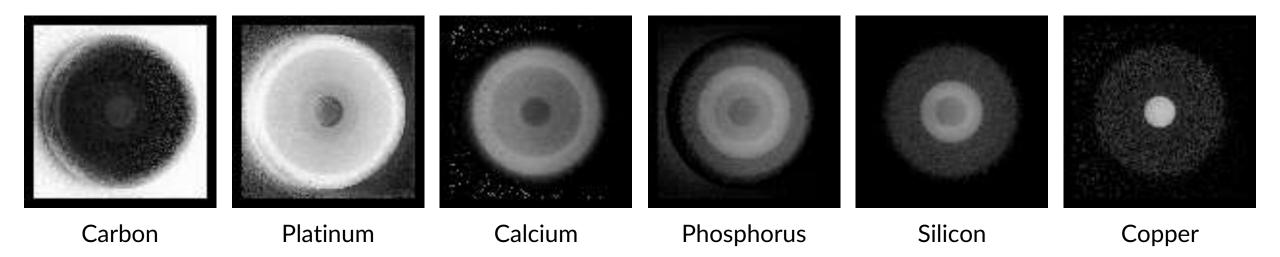


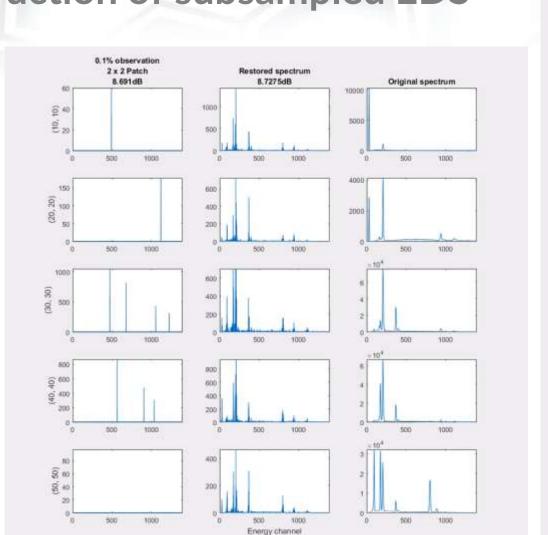
3D visualization of quantified block

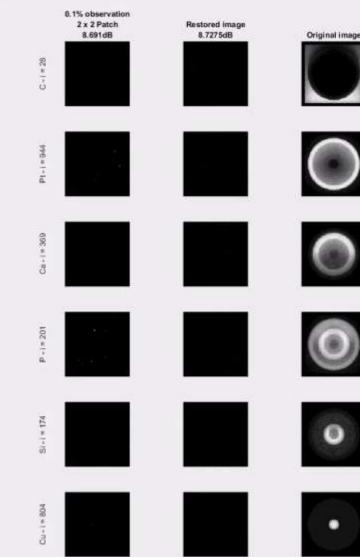


How about EDS?

- Simulated 3D data cube using DTSA-II:
 - 100 x 100 map 2048 spectral channels
- Fully sampled quantification data:







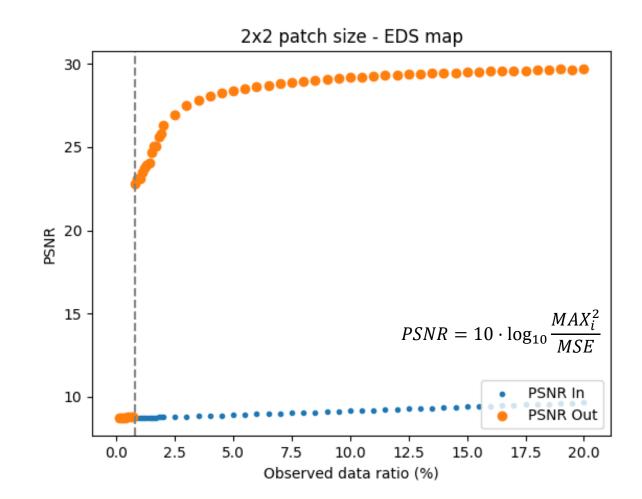
BPFA reconstruction of subsampled EDS

- Tested both 2 x 2 and 4 x 4 patch sizes
- Subsample by zeroing out a large fraction of the simulated voxels
- Analyzed reconstruction output as function of observation ratio

NIST

Reconstruction "phase transition"

- Donoho-Tanner transition
 - Reconstruction either fails completely, or does pretty well
 - Abrupt onset of success at a certain signal level

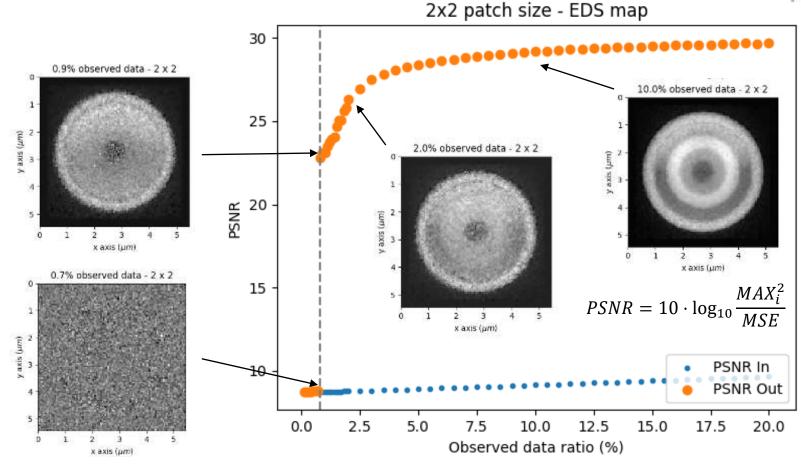


MATERIAL MEASUREMENT LABORATORY

Original data

Reconstruction "phase transition"

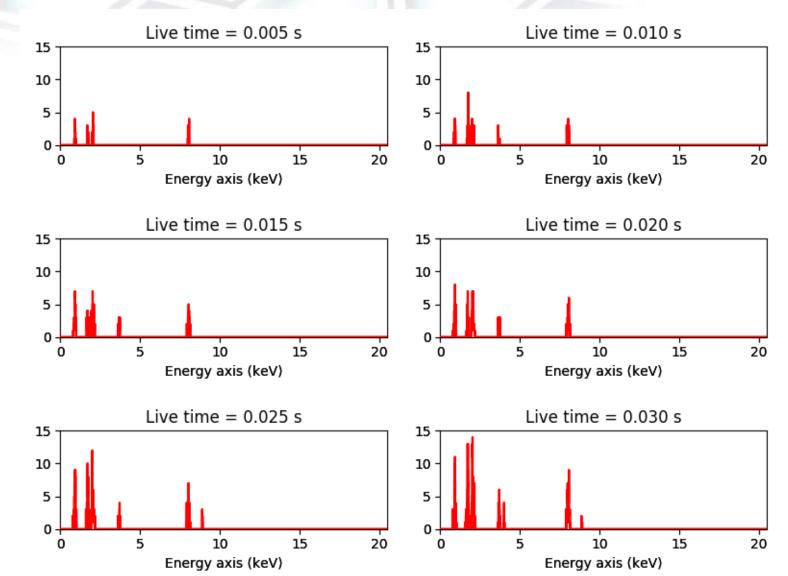
- Donoho-Tanner transition
 - Reconstruction either fails completely, or does pretty well
 - Abrupt onset of success at a certain signal level
 - Quality of reconstruction continues to improve with more data





More realistic test

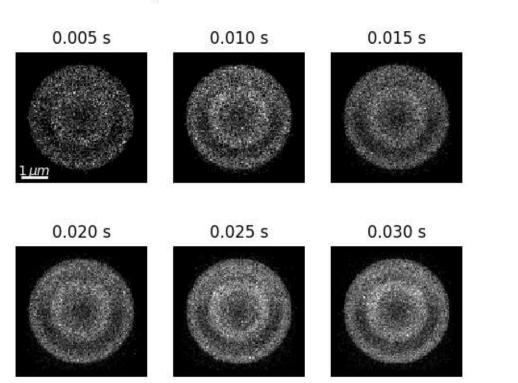
- Random subsampling of entire datacube is not particularly realistic
- Instead, simulate EDS collections with varying dwell times
 - Simulates faster experimental maps, without subsampling locations (or energies)



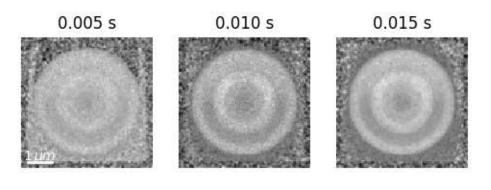


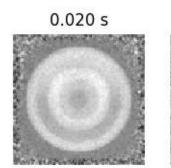
Results of live time variation

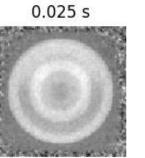
Input at 2.01 keV

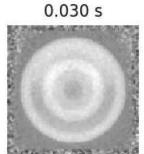


Output at 2.01 keV







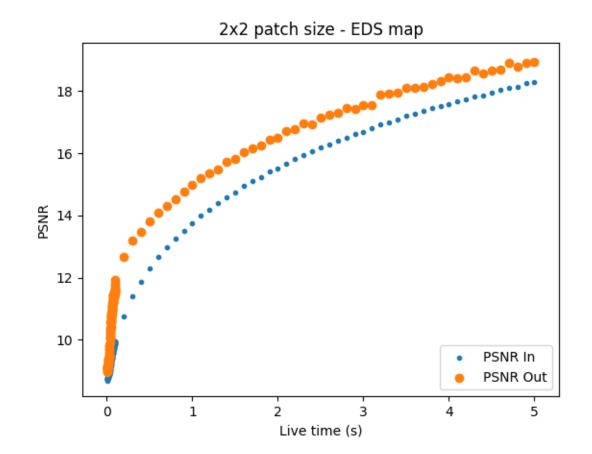


Results of live time variation

- Improvement in PSNR statistics not as dramatic as true random sampling
 - Never reaches high 20s value of previous example
- Reasons?

NIST

- Suspect not sparse enough in energy axis
- Thresholding of continuum X-rays could help
- Still investigating these results





Future directions

Ongoing work

- Improving results of reduced dwell time reconstructions
 - X-ray continuum makes signal non-sparse, leading to bad performance
 - Implement some sort of thresholding, or artificially subsample energy dimension?
 - Eventually need to demonstrate effectiveness on experimental data
- Extension of algorithm to 3D
 - Should be relatively simple, and could enable even lower electron doses
- Extend algorithm to allow incoming information
 - Could make interactive EDS map collections more immediately informative
- Make code more performant
 - Currently single-threaded in Matlab and has not been optimized at all





Thank you!

Questions/comments?

joshua.taillon@nist.gov x2913



MATERIAL MEASUREMENT LABORATORY